

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor(s) : Franz LAERMER  
 Serial No. : 10/519,724  
 Filed : December 28, 2004  
 For : DEVICE AND METHOD FOR THE PRODUCTION OF CHLORINE TRIFLUORIDE AND SYSTEM FOR ETCHING SEMICONDUCTOR SUBSTRATES USING THIS DEVICE  
 Examiner : Rakesh Dhingra  
 Art Unit : 1792  
 Confirmation No. : 5180

Mail Stop Amendment  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on August 10, 2009.

Signature: /Elizabeth Tretter/  
 Elizabeth Tretter

**AMENDMENT**

SIR:

In response to the Office Action of February 10, 2009, (the three-month response date for which is May 10, 2009), kindly amend the above-captioned application without prejudice as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.

Applicants respectfully request a three month extension of time in which to file this response and provide payment of the required fee in the accompanying transmittal.